



PATENT
Docket No.150.00560104

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Lee et al.) Group Art Unit: 1765
Serial No.: 10/050,639) Examiner: Deo, Duy Vu
Confirmation No.:6476)
Filed: 15 January 2002)
For: METHOD AND COMPOSITION FOR SELECTIVELY ETCHING AGAINST
COBALT SILICIDE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
P.O. Box 2327
Arlington, VA 22202

Sir:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 *et. seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. Pursuant to the provisions of M.P.E.P. §609, Applicants further request that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

Since this Supplemental Information Disclosure Statement is submitted after the receipt of an Office Action in the above-identified patent application, Applicants have included the fee of \$180 under 37 C.F.R. §§1.97(c) and 1.117(p). Please charge any additional fees or credit any overpayment to Deposit Account No. 13-4895.

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Supplemental Information Disclosure Statement

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Applicant(s): Lee et al.

Serial No.: 10/050,639

Confirmation No.: 6476


Filed: 15 January 2002

For: METHOD AND COMPOSITION FOR SELECTIVELY ETCHING AGAINST COBALT SILICIDE

The Examiner is invited to contact Applicants' Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper is being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Assistant Commissioner for Patents, P.O. Box 2327, Arlington, VA 22202, on this 19th day of July, 2002.


Mark Gebhardt

19 July 2002
Date

Respectfully submitted for

Micron Technology, Inc.

By

Muetting, Raasch & Gebhardt, P.A.

P.O. Box 581415

Minneapolis, MN 55458-1415

Phone: (612)305-1220

Facsimile: (612)305-1228

Customer Number 26813



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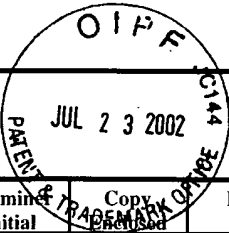
By: 

Mark J. Gebhardt

Reg. No. 35,518

Direct Dial (612)305-1216

INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 150.00560104	Serial No.: 10/050,639
	Applicant(s): Lee et al.	Confirmation No.: 6476
	Application Filing Date: January 15, 2002	Group: 1765
	Information Disclosure Statement mailed:	

**U.S. PATENT DOCUMENTS**

Examiner Initial	Copy Enclosed	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
		5,242,831	09/07/93	Oki			
		5,428,234	06/27/95	Sumi			
		5,566,198	10/15/96	Horie et al.			
		5,824,200	10/20/98	Kitajima et al.			
		5,838,028	11/17/98	Horie et al.			
		6,002,202	12/14/99	Meyer et al.			
		6,110,839	08/29/00	Nakano et al.			
		6,116,254	9/12/00	Shiramizu			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

Examiner Initial	Copy Enclosed	Document Description

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EXAMINER	Date Considered
<p>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	